

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yoichiro Ohta )  
Serial No.: 10/796,344 )  
Conf. No.: 1978 )  
Filed: 3/9/2004 )  
For: VACUUM PROCESSING )  
APPARATUS )  
Art Unit: 1792 )  
Examiner: Lund, Jeffrie Robert )

**AMENDMENT F**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed December 23, 2008, please amend the application as follows: